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S/N 08/757.873

PATENT

TENT AND TRADEMARK OFFICE

Applicant: Umesh K. Mishra, et al.

Examiner: S. Mulpuri

Serial No.: 08/757,873

IN THE UNITED

Group Art Unit: 1107

Filed:

November 27, 1996

Docket: 30794.12U\$01

Title:

UV ASSISTED GALLIUM NITRIDE GROWTH

## **AMENDMENT**

Assistant Commissioner for Patents Washington, D.C.

Dear Sir:

In response to the Office Action dated June 26, 1997, and in response to the telephone interviews of November 5, 1997, please amend the application as follows:

## IN THE CLAIMS

1. (Twice Amended) A method of growing a nitride layer on a substrate, comprising the steps of:

adding a plasma [ molecule ] gas. the gas selected from a group consisting of mercury, argon, neon, and xenon, to a chamber containing a nitrogen-bearing molecule;